	Hits	Search Text	DBs
1	12	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr) with (layer or coat\$3)) and (coercivity or coerciveness) and (mask\$3 same (resist or photoresist or photosensitive) same pattern\$4) and ((implant\$3 or dop\$3) with (Ar or argon or ion))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
2	0	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) with (layer or coat\$3)) and (((resist or photoresist or photosensitive) with pattern\$3) same selectiv\$4 same (implant\$3 or dop\$3) same (coercivity or coerciveness or Oe or Oersted))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
3	0	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) with (layer or coat\$3)) and ((resist or photoresist or photosensitive) same pattern\$3) and (selectiv\$4 same (implant\$3 or dop\$3) same (coercivity or coerciveness or Oe or Oersted) same (ion))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
4	3	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) with (layer or coat\$3)) and ((resist or photoresist or photosensitive) same pattern\$3 same mask\$3) and (selectiv\$4 same (implant\$3 or dop\$3) same (argon or Ar))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
5	6	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) same (layer or coat\$3) same (resist or photoresist or photosensitive) same pattern\$3 same mask\$3) and (selectiv\$4 same (implant\$3 or dop\$3) same (argon or Ar))	110,010,

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	Hits	Search Text	DBs
6	13	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) same (layer or coat\$3) same (resist or photoresist or photosensitive) same pattern\$3 same mask\$3) and (selectiv\$4 same (implant\$3 or dop\$3) same (argon or Ar or ion))	
7	29	((magnetic or ((Co or cobalt or Ni or nickel) adj alloy) or (magnetic adj record adj medi\$2) or (MR or magneto\$1resistive)) same (resist or photoresist\$3 or photosensitive) same pattern\$3 same mask\$3) and (selectiv\$4 same (implant\$3 or dop\$3) same (argon or Ar or ion))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
8	74	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) with (layer or coat\$3)) and ((resist or photoresist or photosensitive) same pattern\$3) and (selectiv\$4 same (implant\$3 or dop\$3) same (ions or argon))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
9	10	(((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) with (layer or coat\$3 or deposit\$3)) same selectiv\$4 same (implant\$3 or dop\$3) same (ions or argon)) and (coercivity or coerciveness or (magnetic with properties))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
10	1	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) same selectiv\$4 same (implant\$3 or dop\$3) same (ions or argon)) and (coercivity or coerciveness or (magnetic with properties)) and (DC same magneti\$5 same bias)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB

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	Hits	Search Text	DBs
11	357	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) same (implant\$3 or dop\$3) same (ions or argon)) and ((coercivity or coerciveness or (magnetic with properties) or Oe or oersted) same (change or variation or varying or lower\$3 or decreas\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
12	18	<pre>(((magnetic with propert\$3) or coercivit\$3) same (modification or modif\$4) same ((ion or atom) with (dop\$3 or implantation or implant\$3)))</pre>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
13	15	<pre>(((magnetic with propert\$3) or coercivit\$3) same (modification or modif\$4)) and ((ion or atom) with (dop\$3 or implantation or implant\$3)) and ((photolithography or photoresist\$4 or (pattern\$4 with selective\$2)) same mask\$3)</pre>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
14	1107	<pre>((implant\$5 or dop\$3) with (ions or argon)) and ((coercivity or coerciveness or (magnetic with properties) or Oe or oersted) same (change or variation or varying or lower\$3 or modif\$4 or decreas\$3)) and (((photoresist or resist) same mask\$4) or photolithographically)</pre>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
15	0	<pre>(((implant\$5 or dop\$3) with (ions or argon)) same (coercivity or coerciveness or (magnetic with propert\$3) or oersted) same (chang\$3 or variation or varying or modification or modifying or modify or modified)) and (((photoresist or resist) same mask\$4) or photolithographically) and ((magneti\$1ation or magneti\$4) same DC same bias\$3 same switch\$4)</pre>	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB

	Hits	Search Text	DBs
16	7	(((implant\$5 or dop\$3) with (ions or argon)) same (coercivity or coerciveness or (magnetic with propert\$3) or oersted) same (chang\$3 or variation or varying or modification or modifying or modify or modified)) and (((photoresist or resist) same mask\$4) or photolithographically)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
17	20	(((implant\$5 or dop\$3 or bombard\$4) with (ions or argon)) same (coercivity or coerciveness or oersted) same (chang\$3 or variation or varying or modification or modifying or modify or modified))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
18	2	(((implant\$5 or dop\$3 or bombard\$4) with (ions or argon)) same (Oersted with "5000"))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
19	4	((implant\$5 or dop\$3 or bombard\$4) same (Oersted with "5000"))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
20	1	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) with (layer or coat\$3)) and ((resist or photosensitive) same stamp\$3 same imprint\$4 same pattern\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
21	108	((magnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) with (layer or coat\$3)) and ((resist or photoresist or photosensitive) same stamp\$3 same pattern\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
22	23	(((magnetic or MR or ferromagnetic or NiFe or permalloy or Ni\$1Co or Co\$1Cr or ((Co or cobalt or Ni or nickel) adj alloy)) with (layer or coat\$3 or deposit\$3)) same (resist or photoresist or photosensitive) same stamp\$3 same pattern\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
23	2	("6265888").PN.	USPAT; EPO; JPO; DERWENT; IBM_TDB

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	Hits	Search Text	DBs
24	166	•	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
25	26		USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
26	35	<pre>(((implant\$5 or dop\$3 or bombard\$4) with (ions or argon or implantation or implant\$3)) same (coercivity or coerciveness or oersted) same (reduc\$4 or lower or decrease))</pre>	USPAT; US-PGPUB; EPO; JPO;
27	2	("6331634").PN.	USPAT; EPO; JPO; DERWENT; IBM_TDB
28	2	("6331364").PN.	USPAT; EPO; JPO; DERWENT; IBM_TDB
29	191	(((implant\$5 or dop\$3 or bombard\$4) with (ions or argon)) same (coercivity or coerciveness or oersted or (field with strength)) same (reduc\$4 or lower))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
30	1	("6610456").PN.	USPAT; US-PGPUB
31	9	(("6338811") or ("6665077") or ("6403170") or ("6293135") or ("6333067") or ("6589676") or ("6673429") or ("6596341") or ("6558771")).PN.	USPAT; US-PGPUB
32	2	(((implant\$5 or dop\$3 or bombard\$4) with (ions or argon or implantation or implant\$3)) same (coercivity or coerciveness or oersted) same (reduc\$4 or lower or decrease or chang\$3) same (selectiv\$4 or pattern\$4 or mask\$4)) and (magnetic with (layer\$3 or deposit\$4 or coat\$4 or film or form\$3)) and (magnetic near3 record\$4 near3 medi\$2) and (data near3 (track\$3 or zone))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB

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	Hits	Search Text	DBs
33	5	(selectiv\$4 or pattern\$4 or	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
34	1	("20010033453").PN.	USPAT; US-PGPUB